Ref #	Hits	Search Query	DBs	Default Operator	Plurais	Time Stamp
<b>L1</b>	94	(((detect\$3 or identify\$3 or recogniz\$3) near4 wafer) near5 (carrier or casstte)) same (vacuum or pincette or effector or arm)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 09:52
L2	94	L1	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 09:53
L3	. 3	2 and 324/158.1	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 09:57
L4	3	2 and 414/331.15,941.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 10:07
L5	37	("3851972"   "3902615"   "4343584"   "4458152"   "4493606"   "4534389"   "4744713").PN. OR ("4895486").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2007/08/17 09:58
L6	31	("20030046998"   "4786816"   "4803373"   "4819167"   "4895486"   "5225691"   "5239182"   "5308993"   "5466945"   "5483138"   "5604443"   "5636960"   "5783834"   "5844683"   "5906469"   "5981966"   "6013920"   "6075334"   "6145673"   "6147356"   "6188323"   "6236904"   "6300644"   "6303939"   "6388436"   "6430468"   "6542839"   "6745901"   "6789328"   "6827825"   "6915183").PN. OR ("7206663"). URPN.	US-PGPUB; USPAT; USOCR	ÖR	ON	2007/08/17 09:59
L7	6	("5225691"   "6105782"   "6113165"   "6297641").PN. OR ("6745901"). URPN.	US-PGPUB; USPAT; USOCR	OR -	ON	2007/08/17 10:02

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L8	0	2 and 434/219,224,433.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 10:07
S44	27	S43 and "324"/\$.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 08:02
S45 ·	1	S43 and "414"/\$.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 08:03
S46	2	S43 and "700"/\$.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 08:01
S47	14230	(cassette or carrier) and wafer and (vacuum or suction\$3 or pincette or arm or effector) and voltage and ((detect\$3 or measur\$4 or indicat\$3) near5 potential or current)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 08:07
S48	514	S47 and "324"/\$.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 08:02
S49	6	S48 and "414"/\$.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/08/07 08:03

S50	94	(((detect\$3 or identify\$3 or recogniz\$3) near4 wafer) near5 (carrier or casstte)) same (vacuum or pincette or effector or arm)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 08:24
S51	38	("4458152"   "4718023"   "4744709"   "4770590"   "4836733"   "4941800"   "5017082"   "5044752"   "5133635"   "5350269"   "5405230").PN. OR ("5645391"). URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2007/08/07 09:50
S52	553	((carrier or cassette) near5 electrode) same wafer	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 09:55
S53	4	((carrier or cassette) near5 ((slot or groove) near4 electrode)) same wafer	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR.	ON	2007/08/07 09:54
S54	9	S52 and "414"/\$.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 09:56
S55	25	S52 and "324"/\$.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 10:03
S56	30	("4892455" "5028200" "5452795" " 5692878" "5743706" "5782362" "58 87721" "5944038" "5960959" "5975 836" "6102057" "6283827" "667235 8" "6702202" "6710886").PN.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 10:01

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S57		S52 and 206/710-711.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 10:03
S58		S47 and 206/710-711.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 10:04
S59	3	S47 and 700/218.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/08/07 10:05
S60	87483	(cassette or carrier or boat) near5 (slot or groove or opening)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 10:11
S61	6311	((cassette or carrier or boat) near5 (slot or groove or opening)) near8 (wafer or disc)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 10:11
S62	7	((((cassette or carrier or boat) near5 (slot or groove or opening)) near8 (wafer or disc)) near8 electrode)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 10:12
S63	15	((((cassette or carrier or boat) near5 (slot or groove or opening)) near8 (wafer or disc)) near8 (voltage or current))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 10:19

S64	1134	(cassette or carrier or boat) near5 (conductive near (film or pad or electrode))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/08/07 10:19
S65	46	((cassette or carrier or boat) near5 (conductive near (film or pad or electrode))) same wafer	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/07 10:20

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	5402	324/765.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 10:25
L2	8	1 and wafer and ((conductive near3 film) or (conductive near3 propert\$3)) and cassette and electrode and slot and (vacuum near3 pincette) and voltage (conductive near3 suction) and controller.clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 10:43
L3	0	1 and wafer and ((conductive near3 film) or (conductive near3 propert\$3)) and cassette and electrode and slot and (vacuum near3 pincette) and voltage and controller.clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 10:42
L4	0	1 and wafer and ((conductive near3 film) or (conductive near3 propert\$3)) and cassette and electrode and slot and (vacuum near3 pincette) and voltage and (conductive near3 suction) and controller.clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON .	2007/08/17 10:43
L5	0	1 and wafer and ((conductive near3 film) or (conductive near3 propert\$3)) and cassette and electrode and slot and (vacuum near3 pincette) and voltage and controller.clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON .	2007/08/17 10:43
L6	0	1 and wafer and ((conductive near3 film) or (conductive near3 propert\$3)) and cassette and electrode and slot and (vacuum near3 pincette) and controller.clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON-	2007/08/17 10:44
L7	. 1	1 and wafer and ((conductive near3 film) or (conductive near3 propert\$3)) and cassette and electrode and slot and (vacuum or pincette) and controller.clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 10:44

L8	1	1 and wafer and (conductive) and cassette and electrode and slot and (vacuum or pincette) and controller. clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 10:44
L9	. 1	1 and wafer and cassette and electrode and slot and (vacuum or pincette) and controller.clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/08/17 10:45
L10	3	1 and wafer and cassette and electrode and (vacuum or pincette) and controller.clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 10:45
L11	6	1 and wafer and cassette and (vacuum or pincette) and controller. clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/08/17 10:45